

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/808,691  
Applicant: Kostenko et al.  
Art Unit: 1792  
Title: **METHOD AND PROCESSING SYSTEM FOR PLASMA  
ENHANCED CLEANING OF SYSTEM COMPONENTS**  
Attorney Docket: FKL-017  
Confirmation No.: 6065

Electronically Filed

May 19, 2008

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL REJECTION**

This paper is responsive to the final Office Action dated March 18, 2008. The Examiner has indicated that claims 1-24, 28-29, 32-37 and 42-43 are pending in the application, claims 1-5, 8-13 and 16-17 are rejected, and claims 6, 7, 14, 15, 18-24, 28-29, 32-37 and 42-43 are withdrawn from consideration. The present response includes the following:

Amendments to the Specification:	None
Amendments to the Claims:	None
Amendments to the Abstract:	None
Amendments to the Drawings:	None
Remarks:	Pages 2-5
Attachments:	None